

IFW

Docket No.: 060188-0719

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Hidemichi YOSHIDA

Application No.: 10/718,607

Filed: November 24, 2003

For: CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS

: Customer Number: 20277
:
: Confirmation Number: 1705
:
: Group Art Unit: 2822
:
: Examiner: TRINH, Michael Manh
:

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of May 27, 2005 wherein restriction has been required, Applicant hereby elects Group I (claims Claims 1-7) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty
Registration No. 36,139

**Please recognize our Customer No. 20277
as our correspondence address.**

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Date: June 24, 2005